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Attorney Docket No. D/98706R

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors: Philip D. Floyd, et al.

Application No.: 10/014,563 Group: 2872

Filed: 12/14/2001 Examiner: Leonidas Boutsikaris

Title: METHOD AND APPARATUS FOR AN INTEGRATED LASER
BEAM SCANNER

Commissioner for Patents
Washington, D.C. 20231

Sir:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Alexandria, VA 22313-1450, on

May 2, 2003

(Date of deposit)

Gail M. McMillan

Gail M. McMillan
(Signature)

SUBSTITUTE

PRELIMINARY AMENDMENT UNDER 37 C.F.R. § 1.173(b)

ACCOMPANYING REQUEST FOR REISSUE OF U.S. PATENT NO. 6,002,507

Please enter this Substitute Preliminary Amendment into the file of the accompanying U.S. Patent Reissue Application. All new claims have been underscored to comply with 37 CFR 1.173(b).

IN THE CLAIMS:

Please add new claims 21-36 as follows:

21. (NEW) A MEMS formation method including:

providing a SOI wafer including a single crystal silicon layer attached to an insulator layer;
forming at least one first MEMS component by patterning the single crystal silicon layer;

and

depositing at least one layer of polysilicon on the patterned single crystal silicon.

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